

Electronic Supplementary Information (ESI)

Controlled growth of vertical 3D $\text{MoS}_{2(1-x)}\text{Se}_{2x}$ nanosheets for efficient and stable hydrogen evolution reaction

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Simulation details and methods

All the calculations were performed by using density functional theory (DFT) calculations as implemented in the Vienna *ab initio* package (VASP).^{S1} Spin-polarization was considered for all the simulations. The projector augmented wave (PAW) method^{S2} was used to describe electron-ion interaction, while the generalized gradient approximation using the Perdew-Burke-Ernzerhof (PBE) functional was used to describe the electron exchange-correlation. A plane wave basis was set up to an energy cut off of 520 eV. A 6×6 supercell of $\text{MoS}_{2(1-x)}\text{Se}_{2x}$ monolayer was used to investigate the adsorption of hydrogen. A 25 Å vacuum space was constructed to avoid the periodical image interactions between two adjacent $\text{MoS}_{2(1-x)}\text{Se}_{2x}$ layers. The Brillouin zone was integrated using the Monkhorst-Pack scheme^{S3} with $3 \times 3 \times 1$ k -grid. All the atomic positions and cell parameters were relaxed using a conjugate gradient minimization until the force on each atom is less than 0.02 eV Å⁻¹.

Gibbs free-energy of the adsorption atomic hydrogen was calculated using equation (1):

$$\Delta G_H^0 = \Delta E_H + \Delta E_{ZPE} - T\Delta S_H \quad (1)$$

Where ΔE_{ZPE} and ΔS_H are the zero-point energy and entropy difference of hydrogen in the adsorbed state and the gas phase, respectively. The hydrogen adsorption energy ΔE_H for hydrogen in pristine $\text{MoS}_{2(1-x)}\text{Se}_{2x}$ is calculated with the following expression:

$$\Delta E_H = E_{MoS_{2(1-x)}Se_{2x}+H} - E_{MoS_{2(1-x)}Se_{2x}} - \frac{1}{2}E_{H_2} \quad (2)$$

where $E_{MoS_{2(1-x)}Se_{2x}+H}$ and $E_{MoS_{2(1-x)}Se_{2x}}$ are the total energies of $MoS_{2(1-x)}Se_{2x}$ with and without hydrogen adsorption, respectively. E_{H_2} is the energy of a gas phase hydrogen molecule.

The hydrogen adsorption energy ΔE_H for hydrogen adsorbed in $MoS_{2(1-x)}Se_{2x}$ with S and Se vacancies is calculated with the following expression:

$$\Delta E_H = E_{MoS_{2(1-x)}Se_{2x}(\text{vac})+H} - E_{MoS_{2(1-x)}Se_{2x}(\text{vac})} - \frac{1}{2}E_{H_2} \quad (3)$$

where $E_{MoS_{2(1-x)}Se_{2x}(\text{vac})+H}$ and $E_{MoS_{2(1-x)}Se_{2x}(\text{vac})}$ are the total energies of $MoS_{2(1-x)}Se_{2x}$ with vacancy and with and without hydrogen adsorption, respectively.

The calculated frequencies of H_2 gas is 4345 cm^{-1} , 58 cm^{-1} , and 42 cm^{-1} . The contribution from the configurational entropy in the adsorbed state is small and is neglected. So the entropy of hydrogen adsorption as $\Delta S_H = \frac{1}{2}S_{H_2}$ where S_{H_2} is the entropy of molecule hydrogen in the gas phase at standard conditions.^{S4} With these values the Gibbs free energy of equation (1) can be rewritten as:

$$\Delta G_H^0 = \Delta E_H + 0.29 \quad (4)$$

The defect formation energy E_f of S/Se vacancy was calculated from the following expression:^{S5}

$$E_f(\text{Vac}) = E(\text{Vac}) - E(\text{pristine}) + \mu_{\text{S/Se}} \quad (5)$$

where $E(\text{Vac})$ is the total energy of the supercell containing a relaxed S or Se vacancy, $E(\text{pristine})$ is the total energy of the same pristine supercell, $\mu_{\text{S/Se}}$ is the chemical potential of S or Se.

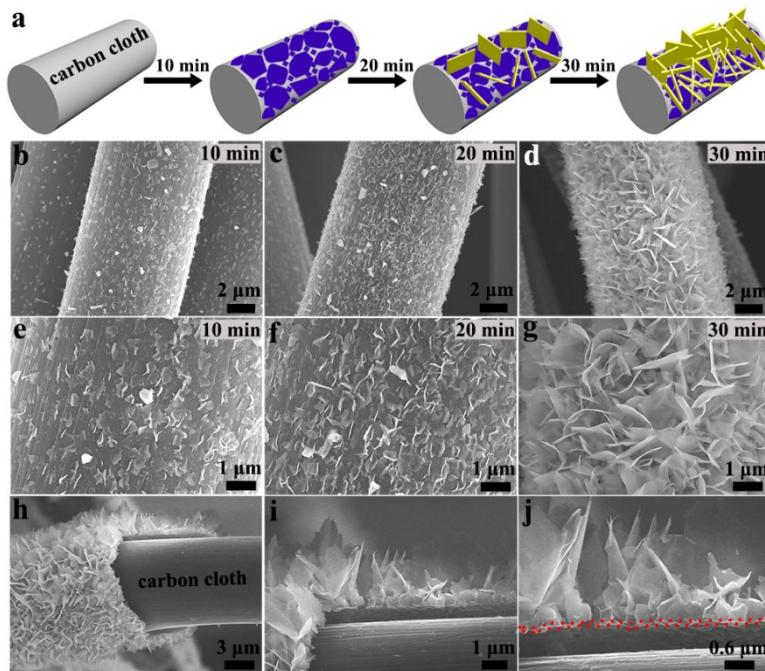


Fig. S1 (a) schematic diagram, (b-g) different magnification SEM images for growth process of vertically oriented 3D $\text{MoS}_{2(1-x)}\text{Se}_{2x}$ nanosheets on carbon cloth with different growth time (10, 20, 30 min), (h-j) different magnification side-view SEM images of vertically oriented 3D $\text{MoS}_{2(1-x)}\text{Se}_{2x}$ nanosheets on the damaged region at the growth time of 30 min.

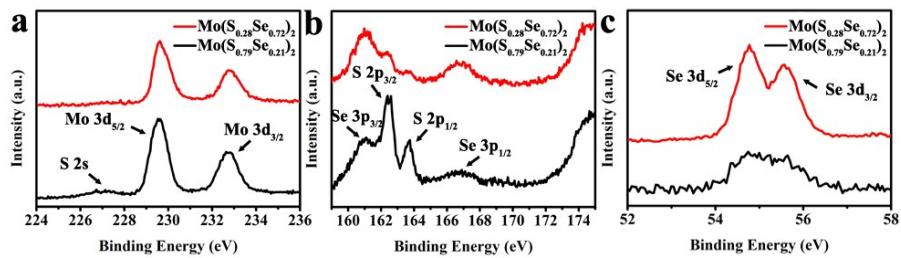


Fig. S2 XPS spectra of Mo 3d, S 2s, S 2p, Se 3p and Se 3d of vertically oriented 3D Mo(S_{0.79}Se_{0.21})₂ and Mo(S_{0.28}Se_{0.72})₂ alloy nanosheets.

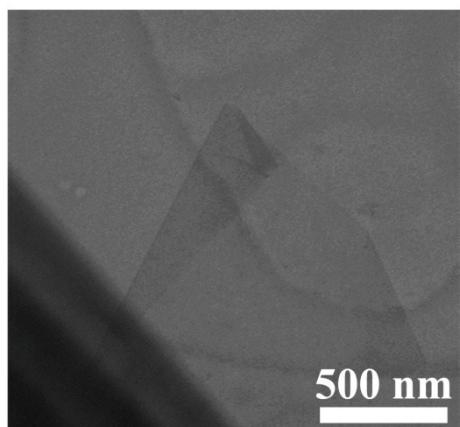


Fig. S3 Dark-field TEM image of vertically oriented 3D $\text{Mo}(\text{S}_{0.53}\text{Se}_{0.47})_2$ nanosheets.

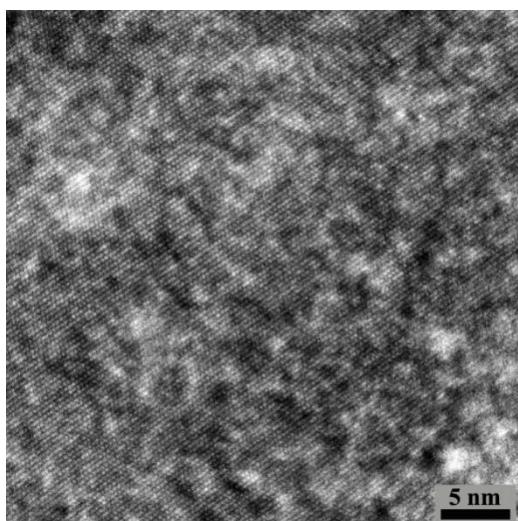


Fig. S4 Large region HRTEM image of vertically oriented 3D Mo_{(S_{0.53}Se_{0.47})₂} nanosheets.

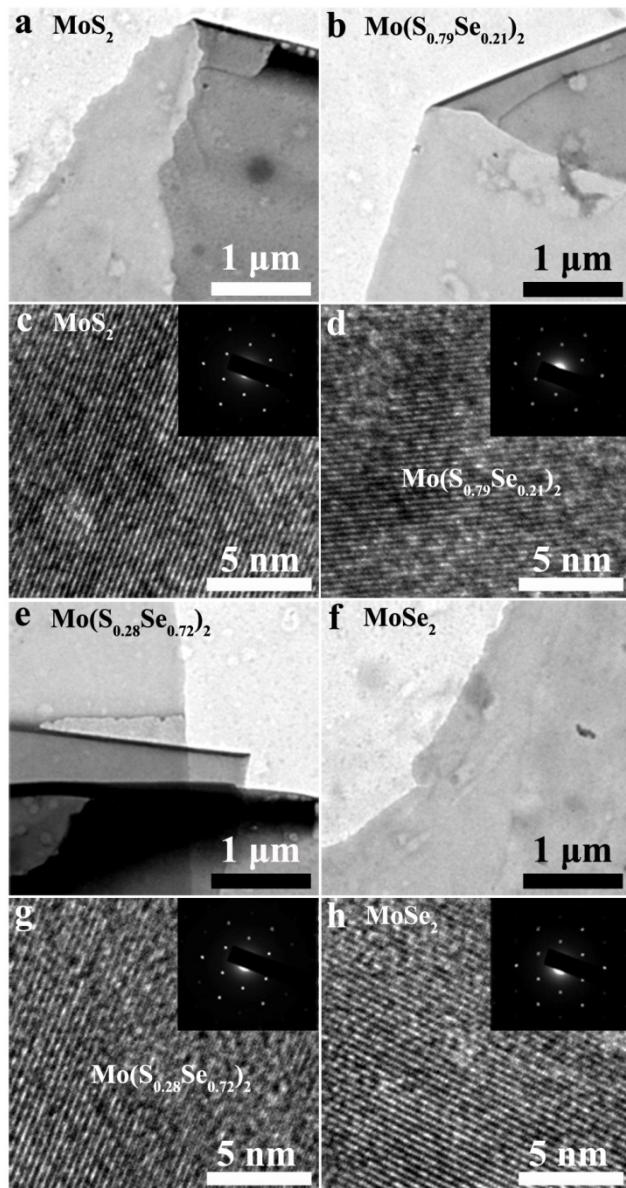


Fig. S5 TEM, HRTEM images and SAED patterns of vertically oriented 3D (a,c) MoS_2 , (b,d) $\text{Mo}(\text{S}_{0.79}\text{Se}_{0.21})_2$, (e,g) $\text{Mo}(\text{S}_{0.28}\text{Se}_{0.72})_2$ and (f,h) MoSe_2 nanosheets.

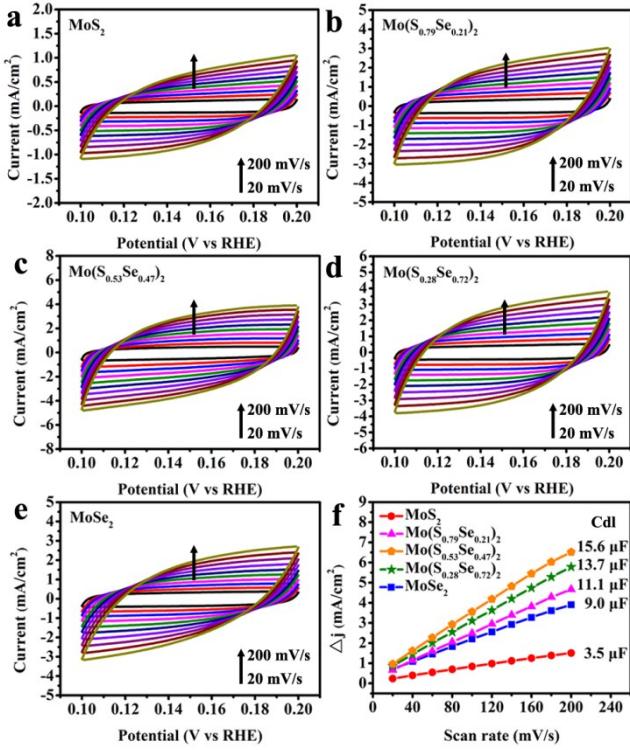


Fig. S6 Cyclic voltammetry curves of vertically oriented 3D $\text{MoS}_{2(1-x)}\text{Se}_{2x}$ alloy nanosheets in the potential region of 0.1-0.2 V vs RHE at different scan rate (20, 40, 60 mV s⁻¹, *etc.*), (b) The current density variation Δj at 0.15 V vs RHE plotted against scan rate linearly fitted to acquire C_{dl} .

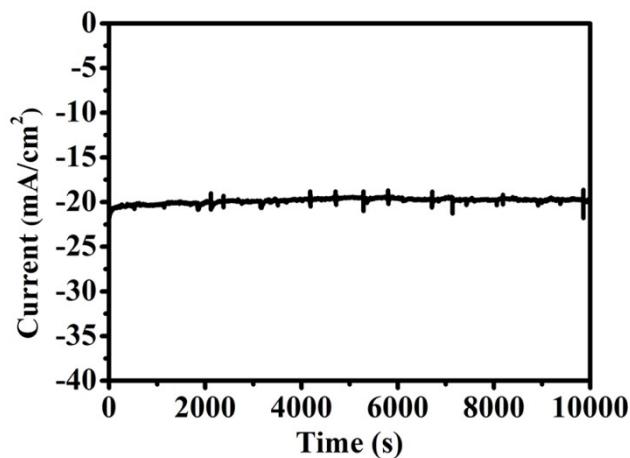


Fig. S7 Chronoamperometric curve of vertically oriented 3D $\text{Mo}(\text{S}_{0.53}\text{Se}_{0.47})_2$ nanosheets on carbon cloth under a constant overpotential of 200 mV for 10000s.

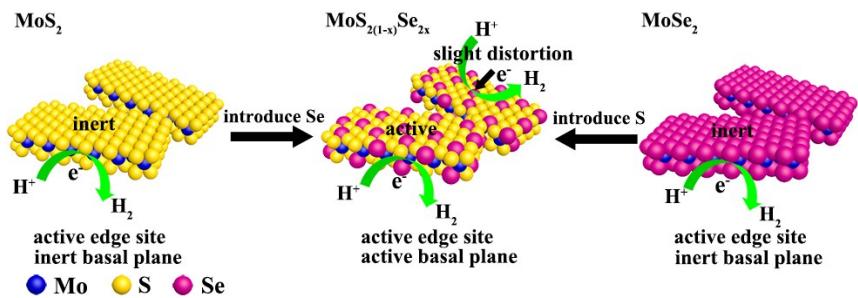


Fig. S8 Schematic illustration of HER electrocatalytic activity for vertically oriented 3D $\text{MoS}_{2(1-x)}\text{Se}_{2x}$ nanosheets.

Table S1 Comparison of previous reported MoS₂ and MoSe₂ based HER electrocatalysts and our electrocatalyst.

Catalyst	Morphology	Oneset potential η_0 (mV)	η_{10} (mV)	Tafel slope (mV dec ⁻¹)	Ref.
MoS _{2(1-x)Se_{2x}}	vertical nanosheet	121	183	55.5	Present work
2H MoS ₂	nanosheet	250	-	75-86	S6
1T MoS ₂		100	-	40	
2H MoS ₂	nanosheet	200	320	117	2
1T MoS ₂		135	187	43	
MoS ₂	nanosheet	155	195	50	8
MoS ₂	porous film	-	-	41-45	S7
MoS ₂	nanosheet	-	-	140-145	S8
MoS ₂	vertical film	200	-	86	S9
MoSe ₂	vertical film	200	-	105	
MoSe ₂	vertical	-	250	59.8	18

		nanofilm			
		macroporous			
MoSe ₂	film	150	250	80	S10
MoSe _{2-x}	nanosheet	170	288	98	S11
MoSe ₂	nanosheet	70	182	69	S12
MoS _{2(1-x)Se_{2x}}	monolayer	-	273	100	10
MoS ₂		-	381	99	
MoSe ₂	nanosheet	-	348	68	S13
Mo(S _x Se _{1-x}) ₂		-	271	57	
MoS ₂		-	219	91	
MoSe ₂	nanoflake	-	181	45	12
MoS _{2(1-x)Se_{2x}}		-	164	48	
MoO ₃ /MoS ₂	core-shell nanowire	150	-	50	S14
MoS ₂ /MoO ₂	porous nanosheet	104	-	76.1	S15
MoS ₂ /MoO ₂	3D heterostructu re	142	-	35.6	S16

MoS ₂ /rGO/P						
PD/O-	3D network	90	-	48		3
MWCNT						
MoO ₂ @N-						
doped MoS ₂	nanosheet	156	-	47.5	S17	

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